

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	IS&R	L1	358	(310/323.01,323.02,323.08).CCLS.	USPAT	2005/12/19 09:16	
2	IS&R	L2	60	(310/323.01,323.02,323.08).CCLS.	US-PGPUB; EPO; JPO; DERWE NT; IBM_T DB	2005/12/19 09:17	
3	IS&R	L3	27	(310/323.16,323.17,323.18).CCLS.	US-PGPUB; EPO; JPO; DERWE NT; IBM_T DB	2005/12/19 09:18	
4	IS&R	L4	200	(310/323.16,323.17,323.18).CCLS.	USPAT	2005/12/19 09:19	
5	IS&R	L5	1789	(310/328,363).CCLS.	USPAT	2005/12/19 09:55	
6	BRS	L6	42	piezoelectric and electrode\$1 same (lanthanum or la) same (sr or strontium) same (titanium or ti)	US-PGPUB; USOCR; EPO; JPO; DERWE NT; IBM_T DB	2005/12/19 10:05	
7	BRS	L7	3	piezoelectric and electrode\$1 same (lanthanum or la) adj3 (sr or strontium) adj3 (titanium or ti)	US-PGPUB; USOCR; EPO; JPO; DERWE NT; IBM_T DB	2005/12/19 10:06	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
8	BRS	L8	1	ifuku-toshihiro.in.	USPAT	2005/12/19 10:33	
9	BRS	L9	26	piezoelectric and (la or lanthanum) adj2 electrode\$1	USPAT	2005/12/19 10:43	
10	BRS	L10	4	piezoelectric and ("la electrode" or "lanthanum electrode")	USPAT	2005/12/19 10:43	

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[Search Summary]

Results of searching in PCT (Full Text) for:

piezoelectric and electrode near (lanthanum near titanium near strontium): 0 records

Refine Search

piezoelectric and electrode near (lanthanum near tita

No records matching your query found in PCT (Full Text)

Search Summary

lanthanum NEAR titanium: 652 occurrences in 318 records.

piezoelectric NEAR lanthanum: 7 occurrences in 4 records.

(lanthanum NEAR titanium AND piezoelectric NEAR lanthanum): 2 records.

lanthanum NEAR titanium: 652 occurrences in 318 records.

electrode NEAR lanthanum: 84 occurrences in 41 records.

(lanthanum NEAR titanium AND electrode NEAR lanthanum): 3 records.

((lanthanum NEAR titanium AND piezoelectric NEAR lanthanum) AND (lanthanum NEAR titanium AND electrode NEAR lanthanum)): 0 records.

lanthanum NEAR strontium: 1073 occurrences in 423 records.

piezoelectric NEAR lanthanum: 7 occurrences in 4 records.

(lanthanum NEAR strontium AND piezoelectric NEAR lanthanum): 3 records.

lanthanum NEAR strontium: 1073 occurrences in 423 records.

electrode NEAR lanthanum: 84 occurrences in 41 records.

(lanthanum NEAR strontium AND electrode NEAR lanthanum): 17 records.

((lanthanum NEAR strontium AND piezoelectric NEAR lanthanum) AND (lanthanum NEAR strontium AND electrode NEAR lanthanum)): 0 records.

((((lanthanum NEAR titanium AND piezoelectric NEAR lanthanum) AND (lanthanum NEAR titanium AND electrode NEAR lanthanum)) AND ((lanthanum NEAR strontium AND piezoelectric NEAR lanthanum) AND (lanthanum NEAR strontium AND electrode NEAR lanthanum)))): 0 records.

Search Time: 3.05 seconds.



Searching PCT (Full Text)...

[[Search Summary](#)]

Results of searching in PCT (Full Text) for:

piezoelectric and electrode near (la near ti near sr): 0 records

Refine Search

piezoelectric and electrode near (la near ti near sr)

No records matching your query found in PCT (Full Text)

Search Summary

la NEAR ti: 2365 occurrences in 1034 records.

piezoelectric NEAR la: 72 occurrences in 66 records.

(la NEAR ti AND piezoelectric NEAR la): 1 record.

la NEAR ti: 2365 occurrences in 1034 records.

electrode NEAR la: 1261 occurrences in 709 records.

(la NEAR ti AND electrode NEAR la): 2 records.

((la NEAR ti AND piezoelectric NEAR la) AND (la NEAR ti AND electrode NEAR la)): 0 records.

la NEAR sr: 1764 occurrences in 725 records.

piezoelectric NEAR la: 72 occurrences in 66 records.

(la NEAR sr AND piezoelectric NEAR la): 1 record.

la NEAR sr: 1764 occurrences in 725 records.

electrode NEAR la: 1261 occurrences in 709 records.

(la NEAR sr AND electrode NEAR la): 11 records.

((la NEAR sr AND piezoelectric NEAR la) AND (la NEAR sr AND electrode NEAR la)): 0 records.

((((la NEAR ti AND piezoelectric NEAR la) AND (la NEAR ti AND electrode NEAR la)) AND ((la NEAR sr AND piezoelectric NEAR la) AND (la NEAR sr AND electrode NEAR la)))): 0 records.

Search Time: 22.45 seconds.





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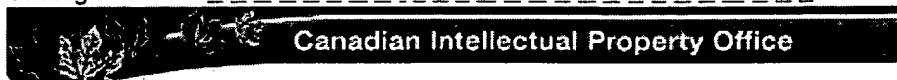
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Query :

((electrode <near> ((lanthanum <or> la

Query: ((electrode <near> ((lanthanum <or> la) <near> (titanium <or> ti)
<near> (strontium <or> sr))) <AND> ((piezoelectric) <in> abstract)

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Last Modified: 2002-12-31



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RESULT LIST

2 results found in the Worldwide database for:

lanthanum and titanium and strontium and piezoelectric in the title or abstract

(Results are sorted by date of upload in database)

1 HIGH DIELECTRIC FILM

Inventor: MATSUKURA KAZUO; MURAKAMI KUNIO;
(+1)

Applicant: UNITIKA LTD

EC:

IPC: C08K3/22

Publication info: **JP58149928** - 1983-09-06

2 Field responsive devices and materials

Inventor:

Applicant: CLEVITE CORP

EC: C04B35/46; C04B35/48; (+4)

IPC:

Publication info: **GB1145371** - 1969-03-12

Data supplied from the **esp@cenet** database - Worldwide

RESULT LIST

4 results found in the Worldwide database for:

piezoelectric in the title AND **electrode** and **la** and **ti** and **sr** in the title or abstract

(Results are sorted by date of upload in database)

- 1 MULTILAYER TYPE PIEZOELECTRIC CERAMIC ELEMENT AND
MULTILAYER TYPE PIEZOELECTRIC ELECTRONIC PART OBTAINED
BY USING THE SAME**
Inventor: TANAKA TOMOYA; TOKASHIKI RYOJI; (+2) Applicant: MURATA MANUFACTURING CO
EC: IPC: C04B35/49; H01L41/083; (+1)
Publication info: **JP2003201175** - 2003-07-15
- 2 MULTILAYER TYPE PIEZOELECTRIC CERAMIC ELEMENT AND
MULTILAYER TYPE PIEZOELECTRIC ELECTRONIC PART OBTAINED
BY USING THE SAME**
Inventor: TANAKA TOMOYA; TOKASHIKI RYOJI; (+2) Applicant: MURATA MANUFACTURING CO
EC: IPC: C04B35/49; H01L41/083; (+1)
Publication info: **JP2003201174** - 2003-07-15
- 3 PIEZOELECTRIC/ELECTROSTRICTIVE ACTUATOR AND
MANUFACTURING METHOD THEREFOR**
Inventor: ITO KEISUKE Applicant: KYOCERA CORP
EC: IPC: H01L41/09; B28B11/04; (+2)
Publication info: **JP2001111127** - 2001-04-20
- 4 CAPACITOR INCORPORATING TYPE PIEZOELECTRIC OSCILLATOR**
Inventor: NAKAKUBO HITOSHI; FUKUOKA SHUICHI; Applicant: KYOCERA CORP
(+2)
EC: IPC: H03H9/17; C04B35/46; (+2)
Publication info: **JP10190399** - 1998-07-21

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RESULT LIST

Approximately **72** results found in the Worldwide database for:

electrode and la and ti and sr in the title or abstract

(Results are sorted by date of upload in database)

1 SEMICONDUCTOR DEVICE

Inventor: TANAKA KEISUKE

Applicant: MATSUSHITA ELECTRIC IND CO LTD

EC:

IPC: H01L27/105

Publication info: **JP2005209870** - 2005-08-04

2 Lithium ion secondary cells positive pole active material and producing method

Inventor: HU XIANG (CN)

Applicant: HU XIANG (CN)

EC:

IPC: H01M4/48; H01M4/58; (+4)

Publication info: **CN1610152** - 2005-04-27

3 Compound having a high conductivity for electrons; electrode for an electrochemical cell which comprises this compound, method for preparing an electrode and electrochemical cell

Inventor: VAN HEUVELN FREDERIK HENDRIK; PLOMP LAMBERTUS; (+1)

Applicant: ENERGIEONDERZOEK CT NEDERLAND

EC: C25B11/04D4; H01B1/08; (+4)

IPC: H01B1/08; H01M4/90; (+2)

Publication info: **NZ528144** - 2005-06-24

4 Sputter target for forming thin film interconnector and thin film interconnector line

Inventor: ISHIGAMI TAKASHI (JP); WATANABE KOICHI (JP); (+3)

Applicant: TOKYO SHIBAURA ELECTRIC CO (JP)

EC: C23C14/16B; C23C14/34B2; (+1)

IPC: C23C14/14; C23C14/34; (+5)

Publication info: **EP1553205** - 2005-07-13

5 Pyroelectric device, method for manufacturing same and infrared sensor

Inventor: TOMOZAWA ATSUSHI (JP); FUJII SATORU (JP); (+3)

Applicant:

EC: G01J5/34; H01L37/02B

IPC: G01J5/00

Publication info: **US2005087689** - 2005-04-28

6 POSITIVE ELECTRODE ACTIVE MATERIAL FOR LITHIUM SECONDARY BATTERY, ITS MANUFACTURING METHOD, AND LITHIUM SECONDARY BATTERY INCLUDING SAME

Inventor: TEI KENSHUKU; KIM GEUN-BAE

Applicant: SAMSUNG SDI CO LTD

EC: C01G53/00D; H01M4/50B2; (+1)

IPC: H01M4/58; C01G53/00; (+2)

Publication info: **JP2005044801** - 2005-02-17

7 NICKEL-HYDROGEN STORAGE BATTERY

Inventor: ENDO MASAHIRO; KIHARA MASARU

Applicant: SANYO ELECTRIC CO

EC:

IPC: H01M4/38; H01M4/52; (+1)

Publication info: **JP2004319429** - 2004-11-11

8 MANUFACTURING METHOD OF ALKALINE STORAGE BATTERY

Inventor: YAMAMURA KOJI; KATSUMOTO MASUMI; (+1)

Applicant: MATSUSHITA ELECTRIC IND CO LTD

EC:

IPC: H01M4/32; H01M4/62; (+1)

Publication info: **JP2004103595** - 2004-04-02

9 Actuator and liquid discharge head, and method for manufacturing liquid discharge head

Inventor: MATSUDA TAKANORI (JP); TAKEDA KENICHI (JP); (+2)

Applicant: CANON KK (JP)

EC: B41J2/16D2; B41J2/16M3D; (+6)

IPC: H01L41/08